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Attorney Docket No. 9409-4

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Robert L. Wood et al. Application No.: 10/661,974

Confirmation No.: 8561 Group Art Unit: 1756

Filed: September 11, 2003

Examiner: John A. McPherson

SYSTEMS AND METHODS FOR FABRICATING MICROSTRUCTURES BY IMAGING A RADIATION SENSITIVE LAYER SANDWICHED BETWEEN OUTER

LAYERS, AND MICROSTRUCTURES FABRICATED THEREBY

March 13, 2006

Commissioner for Patents Box 1450 Alexandria, VA 22313-1450

## STATUS INQUIRY

Sir:

Applicants respectfully inquire as to the status of the above-identified patent application, and when the next communication from the U.S. Patent and Trademark Office regarding this application can be expected.

Respectfully submitted,

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CERTIFICATION OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office via facsimile number 571-273-8300 on March 13, 2006.

Susan E. Freedman

Date of Signature: March 13, 2006